Reference drawing

* This drawing may be revised without any advance notification.
* When designing the equipment layout based on this drawing, please confirm with JEL in advance.

Wafer loading stage

Touch panel

Vision sensor

Ionizer

Signal tower

Emergency stop button

Utility

Provided from under the floor
Single phase: 200 V AC
Clean air: 150 L/min, 0.5 MPa or more

Adjuster with fixing bracket

Flow meter

SAL3482HV

Lid opening/closing device of wafer container

Power receiving breaker

PC power source

USB port

STCR4130S-300-PM

Upper end-effector: For wafer only
Lower end-effector: For interlayer paper only

Carrying angle

Sensor detection angle

45 degrees

72.5 degrees

HOME

None

access

R260 (Minimum rotation radius)

990 (Wafer container stage)

990 (Cassette stage)

980 (Upper end-effector lower level)

870 (Lower end-effector lower level)